

Methoden moderner Röntgenphysik I: Struktur und Dynamik kondensierter Materie

Vorlesung zum Haupt/Masterstudiengang Physik

WS 2008/9

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Location: SemRm 4, Physik, Jungiusstrasse

Thursdays 10.15 – 11.45

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Methoden moderner Röntgenphysik I: Struktur und Dynamik kondensierter Materie

Hard X-Rays - Sources of X-rays, refraction & reflexion **Lecture 2**

23.10.	Introduction	(GG)
30.10.	Sources of X-rays, Refraction and Reflexion	(GG)
6.11.	Kinematical Scattering Theory	(GG)
13.11.	Small Angle and Anomalous Scattering	(GG)
20.11. - 11.12.	Modern Crystallography	(AM)
18.12. - 15. 1.	Coherence base techniques	(CG)
22. 1. - 5. 2.	Soft Matter Applications	(SR)

Coherence of light and matter I: from basic concepts to modern applications

Introduction into X-ray physics: 23.10.-13.11.

Introduction

Overview, Introduction to X-ray Scattering (Scattering from atoms, crystals,..., absorption, reflection, coherence,..)

Sources, Reflection and Refraction

Sources of X-rays, Refraction, reflection, Snell's law, Fresnel equations

Kinematical Diffraction

Diffraction from an atom, molecule, crystal, reciprocal lattice, structure factor,..

SAXS, Anomalous Diffraction

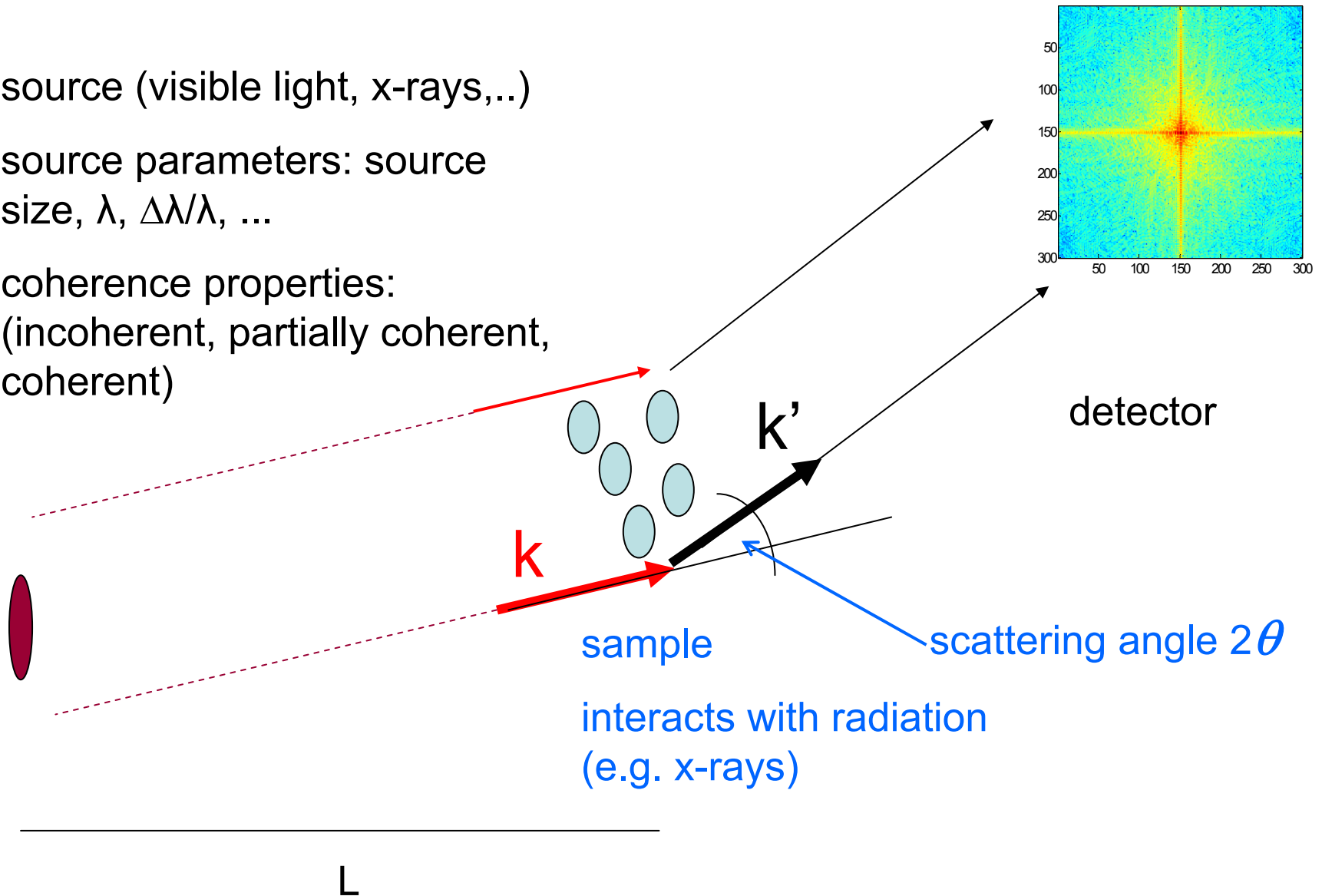
Introduction into small angle scattering and anomalous scattering

Experimental Set-Up for Scattering Experiments

source (visible light, x-rays,..)

source parameters: source size, λ , $\Delta\lambda/\lambda$, ...

coherence properties:
(incoherent, partially coherent, coherent)

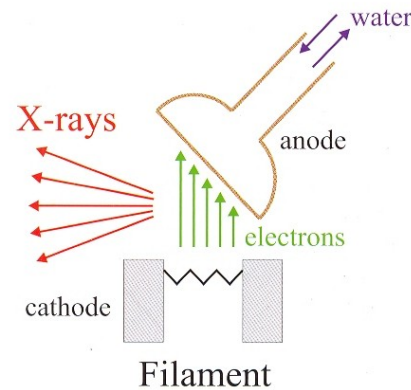


Sources of X-Rays

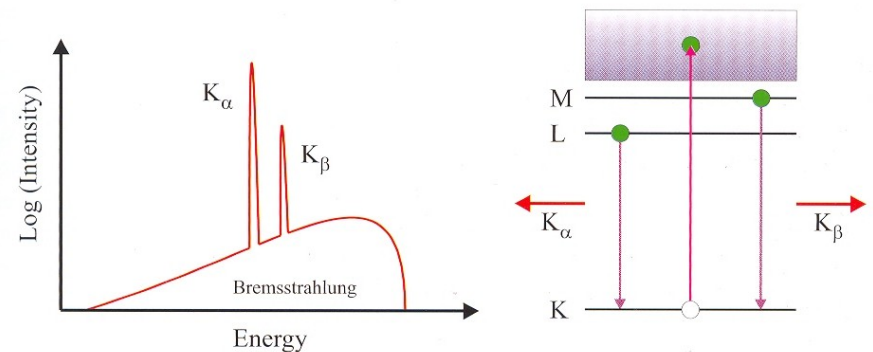
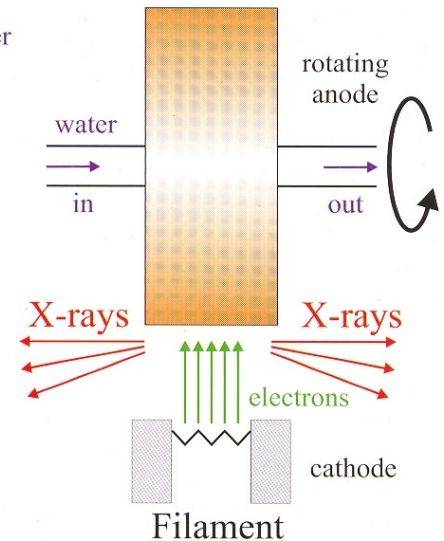
- 1895 discovered by W.C. Röntgen
- 1912 First diffraction experiment (v. Laue)
- 1912 Coolidge tube (W.D. Coolidge, GE)
- 1946 Radiation from electrons in a synchrotron, GE, Physical Review, 71,829(1947)



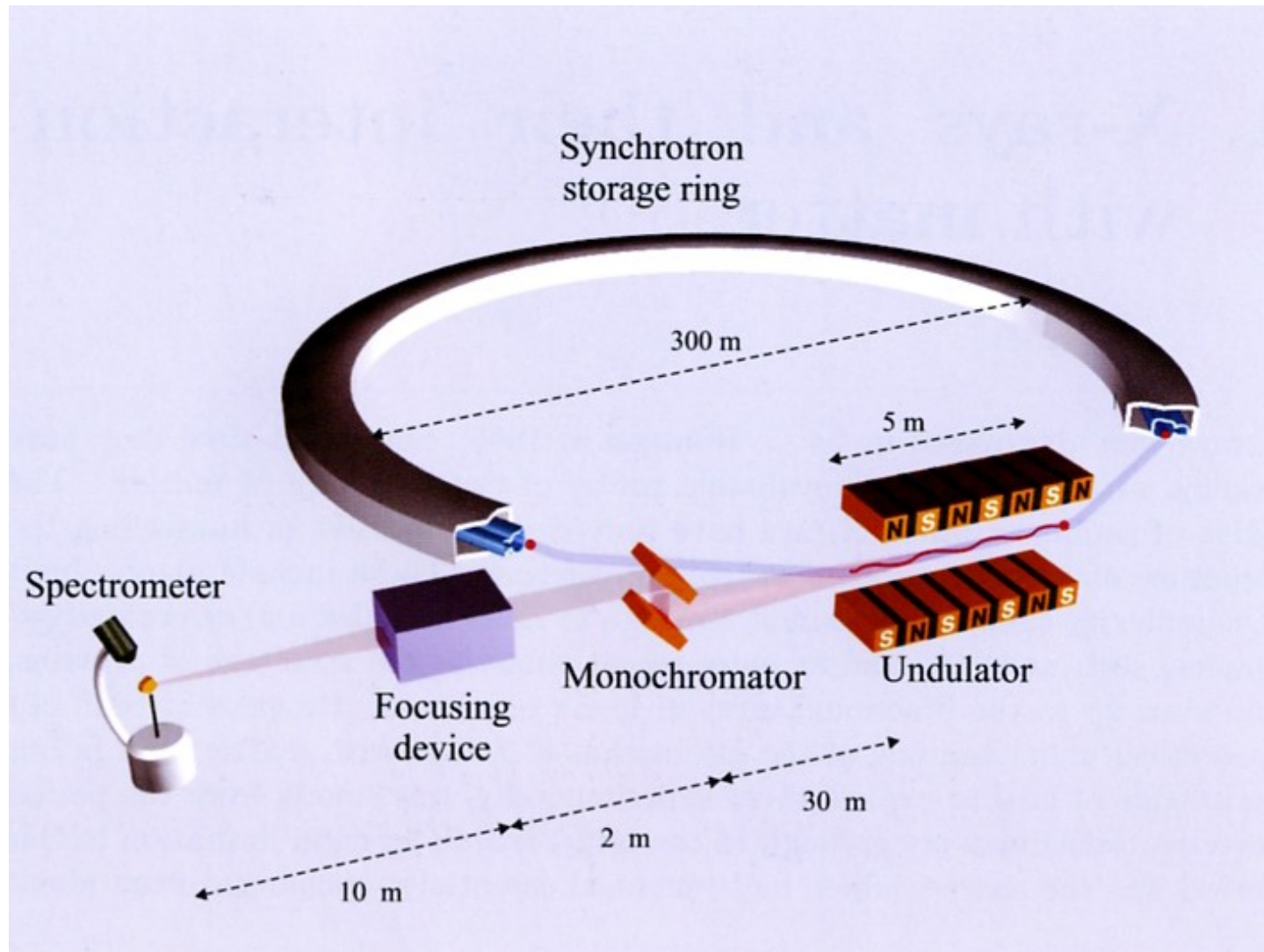
Coolidge Tube



Rotating Anode



Synchrotron Radiation Storage Ring



Photos machines

The three largest and most powerful synchrotrons in the world



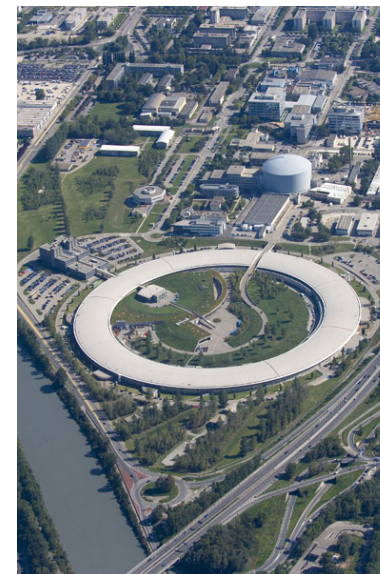
APS, USA



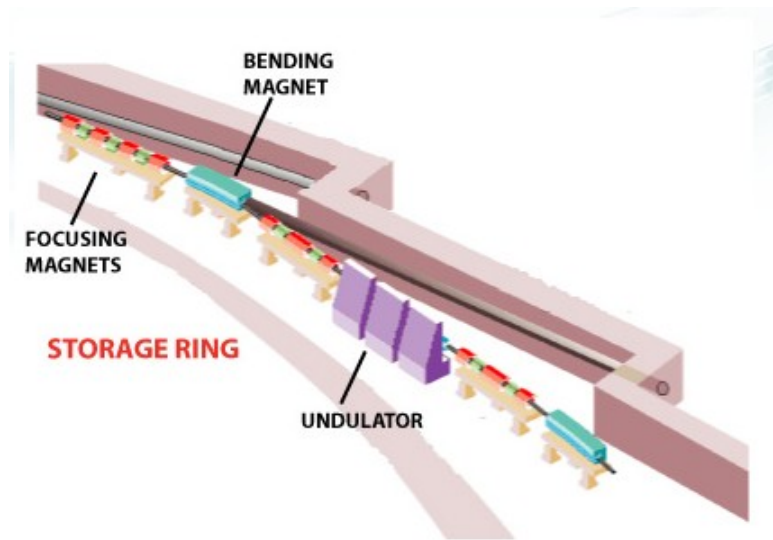
ESRF, Europe-France



Spring-8, Japan



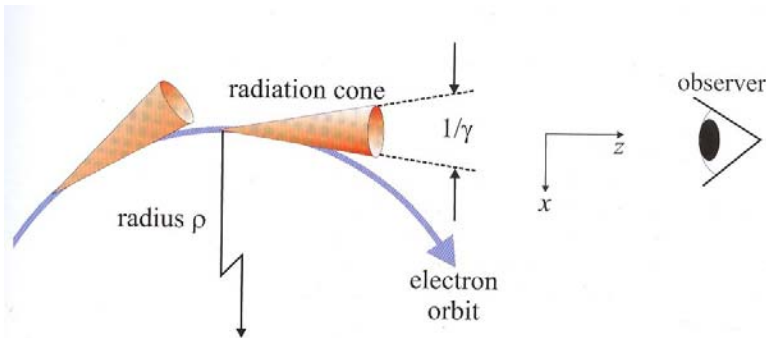
Synchrotron Radiation Primer



Energy E_e of an electron at speed v :

$$E_e = mc^2 / \sqrt{1 - (v/c)^2} = \gamma mc^2$$

For 5 GeV and $mc^2 = 0.511$ MeV get $\gamma \approx 10^4$



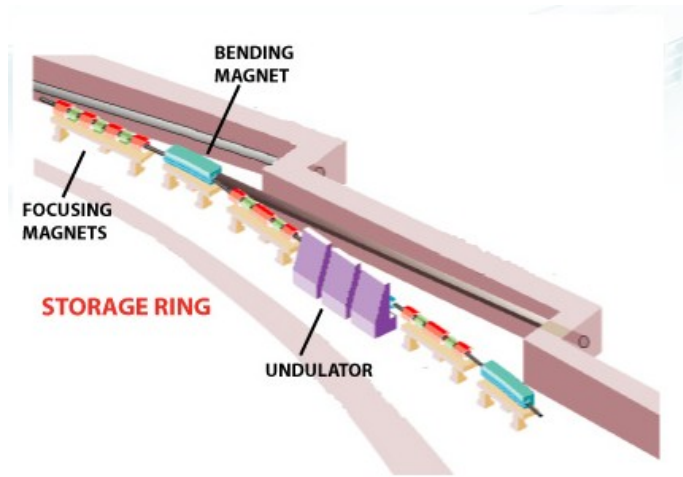
Centrifugal=Lorentz force yields for radius:

$$\rho = \gamma mc / eB = 3.3 E[\text{GeV}] / B[\text{T}] \approx 25 \text{ m}$$

$$E_e \approx 6 \text{ GeV}, B = 0.8 \text{ T}$$

Opening angle is of order $1/\gamma \approx 0.1$ mrad

Bending magnets



Characteristic energy $\hbar\omega_c$ for bend or wiggler:

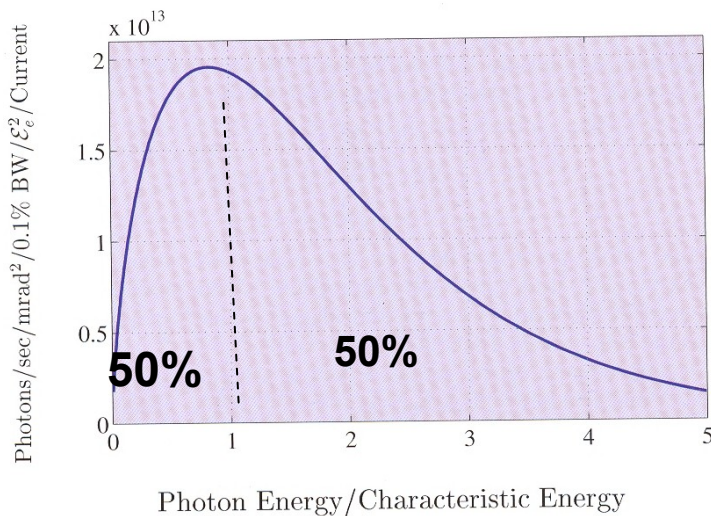
$$\hbar\omega_c [\text{keV}] = 0.665 E_e^2 [\text{GeV}] B(\text{T}) \approx 20 \text{ keV}$$

$$\text{Flux} \sim E^2$$

Energy loss by synchrotron radiation per turn:

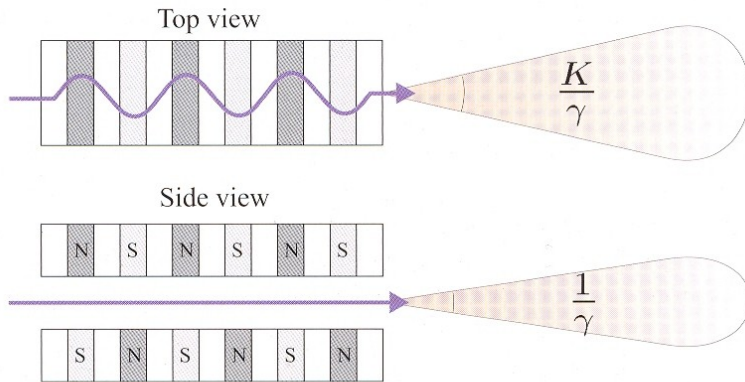
$$\Delta E [\text{keV}] = 88.5 E^4 [\text{GeV}] / \rho [\text{m}]$$

For 1 GeV and $\rho=3.33 \text{ m}$: $\Delta E = 26.6 \text{ keV/turn}$
 For $I=500 \text{ mA} \equiv 0.5 \text{ Cb/s} = 0.5 \times 6.25 \times 10^{18} \text{ e}^-/\text{s}$
 $\rightarrow P = 0.5 \times 6.25 \times 10^{18} \text{ e}^-/\text{s} \times 26.6 \text{ keV}$
 $= 8.3125 \times 10^{22} \times 1.6 \times 10^{-19} = 13.3 \text{ KJ/s} = 13.3 \text{ KW}$

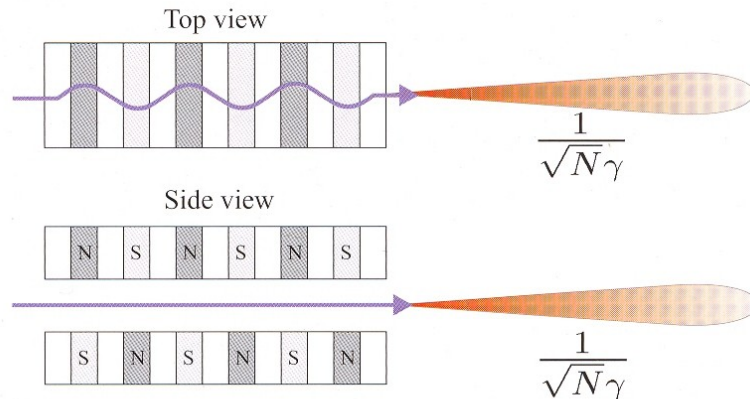


Insertion Devices (wigglers and undulators)

(a) Wiggler



(b) Undulator



Wiggler:

$$P[\text{kW}] = 0.633 E_e^2 [\text{GeV}] B^2 [\text{T}] L [\text{m}] I [\text{A}]$$

$$\text{Flux} \sim E^2 \times N$$

N: number poles

Undulator:

$$k = eB / mc \quad k_u = 0.934 \lambda_u [\text{cm}] B_0 [\text{T}]$$

with λ_u undulator period

undulator fundamental:

$$\lambda_0 = \lambda_u / 2\gamma^2 \{ (1 + k^2/2 + (\gamma\theta)^2) \}$$

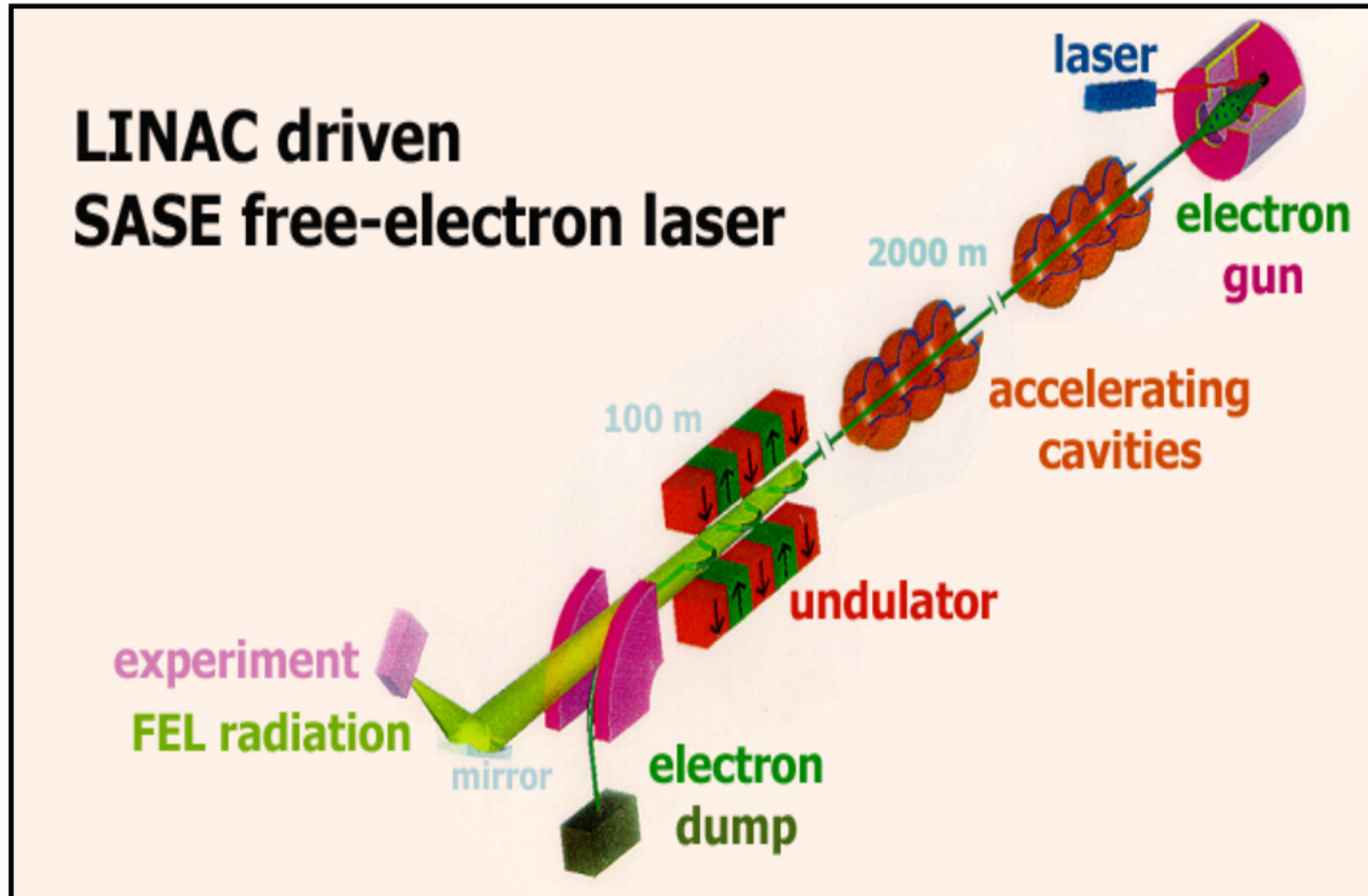
~~on axis~~

$$\text{Flux} \sim E^2 \times N^2$$

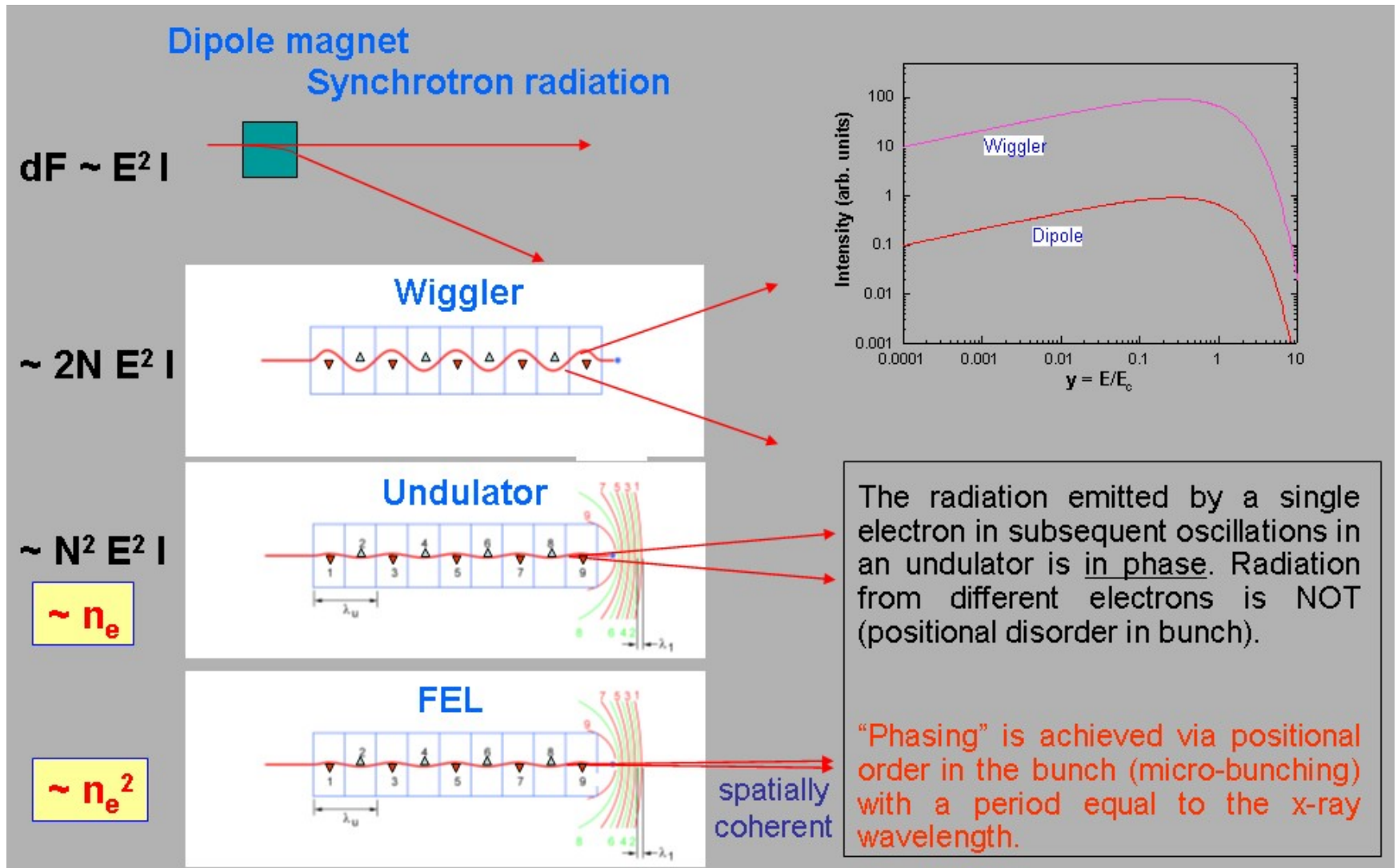
bandwidth:

$$\Delta\lambda/\lambda \sim 1/nN$$

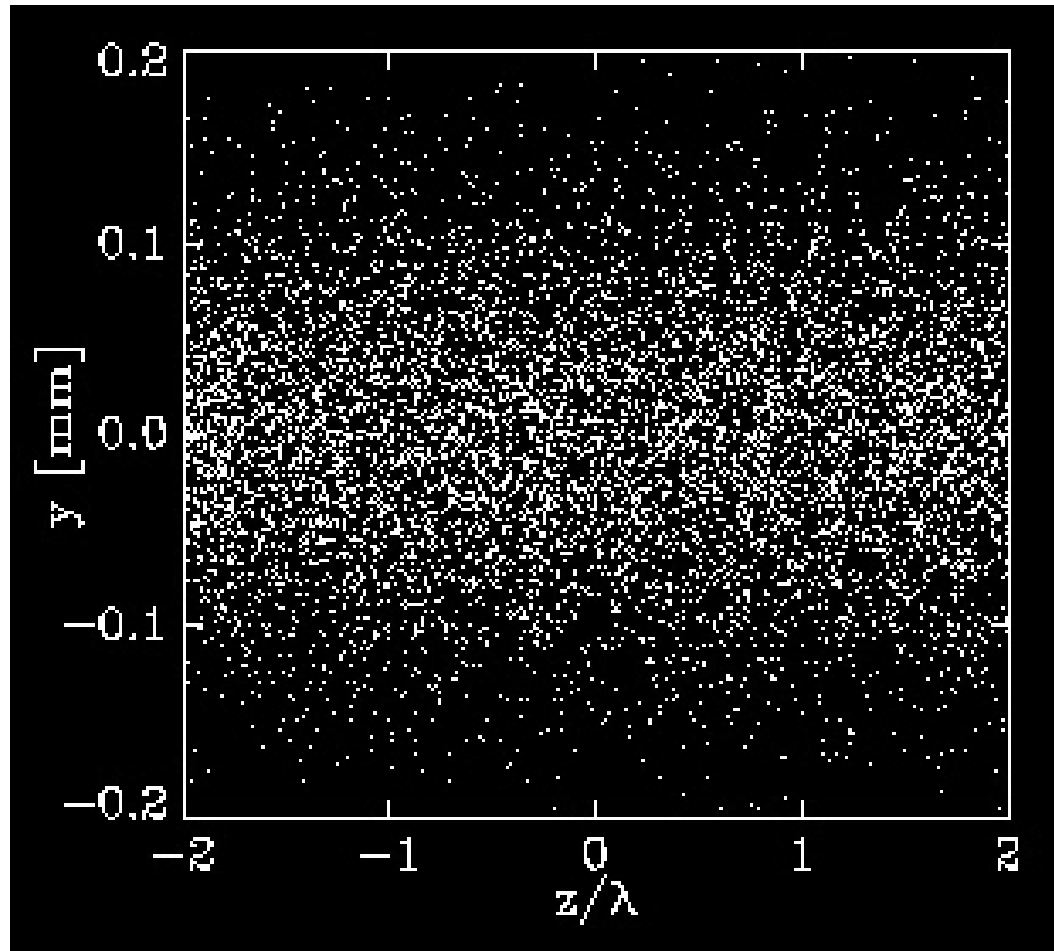
Free Electron Lasers (FELs)



Synchrotron and FEL sources



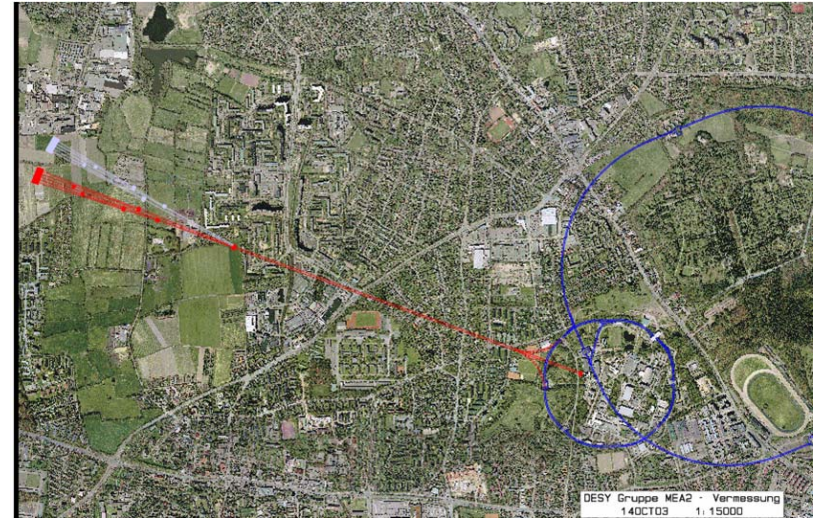
Electron bunching



GENESIS – simulation for TTF parameters

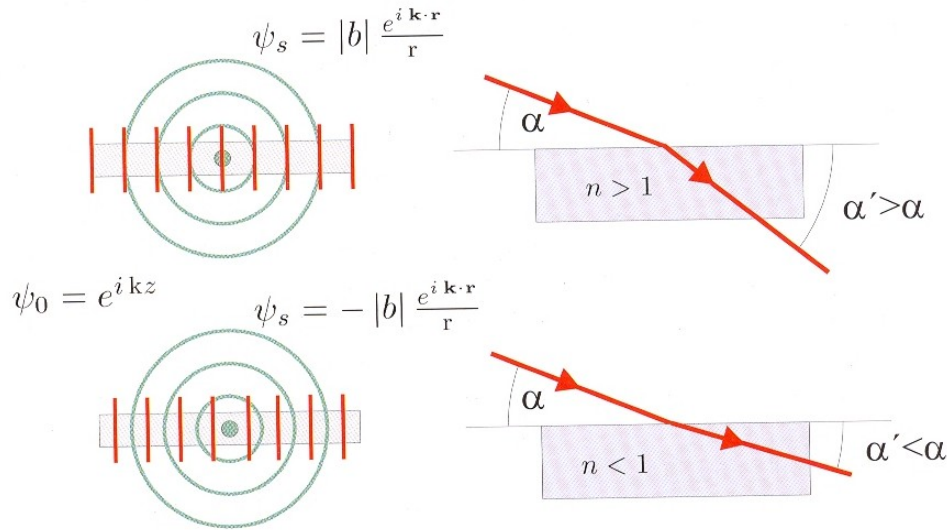
Courtesy Sven Reiche
(UCLA)

VUV and X-Ray FELs



Refraction and Reflexion from Interfaces

Refraction and Reflexion from Interfaces



Rays of light propagating in air change direction when entering glass, water or another transparent material.

Governed by Snell's law:

$$\cos \alpha / \cos \alpha' = n \text{ (refractive index)}$$

$$n = n(\omega) \quad 1.2 < n < 2 \text{ visible light}$$

$$n < 1 \text{ X-rays } (\alpha' < \alpha)$$

$$n = 1 - \delta \quad \delta \approx 10^{-5}$$

Note: spherical wave $\exp(i\mathbf{k}'\cdot\mathbf{r})$

$$k' = nk = (n/c)\omega = \omega/v$$

with $v=c/n$ phase velocity

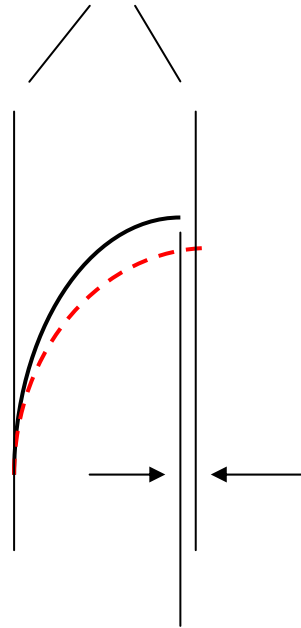
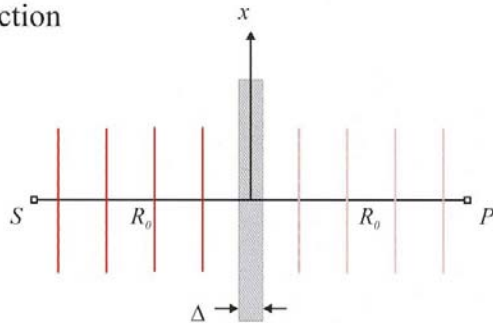
($v > c$ for $n < 1$; but group velocity $d\omega/dk \leq c$)

total external reflexion:

for $\alpha < \alpha_c$ (critical angle)

Refractive Index

Refraction



Phase difference

Refractive picture:

Consider plane wave impinging on a slab with thickness Δ and refractive index n . Evaluate amplitude at observation point P (compared to the situation without slab).

$$\left. \begin{array}{l} \text{no slab: } \exp(ik\Delta) \\ \text{slab: } \exp(ink\Delta) \end{array} \right\} \begin{array}{l} \text{phase difference:} \\ \exp(i(nk-k)\Delta) \end{array}$$

amplitude:

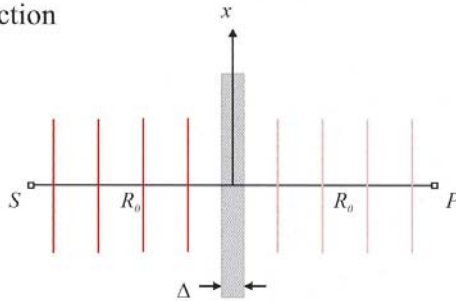
$$\begin{aligned} \Psi_{\text{tot}}^P / \Psi_0^P &= \exp(ink\Delta) / \exp(ik\Delta) \\ &= \exp(i(nk-k)\Delta) \end{aligned}$$

$$\exp(i\alpha) = \cos\alpha + i\sin\alpha \xrightarrow{\alpha \text{ small}} 1+i\alpha$$

$$\Psi_{\text{tot}}^P \approx \Psi_0^P [1 + i(n-1)k\Delta] \quad (\$)$$

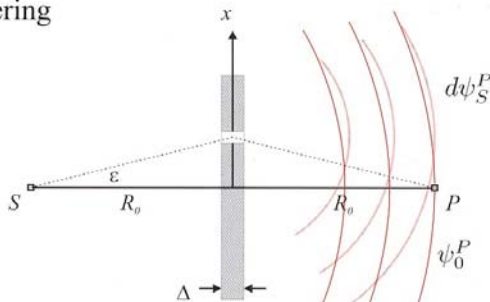
Refractive Index

Refraction



$$\psi_{tot}^P = \psi_0^P e^{i(nk-k)\Delta} \approx \psi_0^P [1 + i(n-1)k\Delta]$$

Scattering



$$\phi(x, y) = k(2R - 2R_0) \approx k(x^2 + y^2)/R_0$$

$$d\psi_S^P = \left(\frac{e^{ikR_0}}{R_0} \right) \text{ incident wave}$$

$$(\rho \Delta dx dy) \text{ number of scatterers}$$

$$\left(-b \frac{e^{ikR_0}}{R_0} \right) \text{ spherical wave from one scatterer}$$

$$e^{i\phi(x,y)} \text{ apart from this phase factor}$$

$$\psi_{tot}^P = \psi_0^P + \int d\psi_s^P = \psi_0^P \left[1 - i \frac{2\pi \rho b \Delta}{k} \right]$$

Scattering picture:

$$R = \sqrt{R_0^2 + x^2} = \sqrt{R_0^2(1 + x^2/R_0^2)}$$

$$\approx R_0 \sqrt{1 + x^2/R_0^2 + x^4/4R_0^4}$$

$$= R_0 \sqrt{[1 + x^2/2R_0^2]^2} = R_0 [1 + x^2/2R_0^2]$$

phase difference ($2kR$) btw. direct rays and rays following path R ;

$$2kx^2/2R_0 = kx^2/R_0$$

include y direction:

$$\exp(i\Phi(x,y)) = \exp(i(x^2 + y^2)k/R_0)$$

amplitude at P:

$$d\psi_S^P \approx$$

$$\exp(ikR_0)/R_0 \quad (\rho \Delta dx dy) \quad (b \exp(ikR_0)/R_0) \quad \exp(i\Phi(x,y))$$

incident wave

number of scatters
in volume element
 $\rho dx dy$

scattered wave
from 1 scatterer

phase factor

Refractive Index

$$\Psi_S^P = \int d\Psi_S^P = -\rho b \Delta \{ \exp(i2kR_0) \} / R_0^2 \cdot \frac{\int \exp(i\Phi(x,y)) dx dy}{i\pi R_0 / k} \quad [\text{Ref. 1}]$$

Amplitude at P without slab:

$$\Psi_0^P = \{ \exp(ik2R_0) \} / 2R_0$$

$$\Psi_{\text{tot}}^P = \Psi_0^P [1 - i2\pi\rho b \Delta / k] \equiv (\$) \equiv \Psi_0^P [1 + i(n-1)k\Delta]$$

$$\rightarrow n = 1 - 2\pi\rho b / k^2 = 1 - \delta$$

If a homogeneous electron density ρ is replaced by a plate composed of atoms:

$$\rho = \rho_a f^0(0)$$

Number density x atomic scattering factor

$$\delta = 2\pi\rho_a f^0(0) r_0 / k^2$$

Total external reflexion ($\alpha'=0$) for $\alpha = \alpha_c$:

$$\cos\alpha = n \cos\alpha'$$

$$\cos\alpha_c = 1 - \delta = 1 - \alpha_c^2 / 2$$

$$\alpha_c = \text{sqrt}(2\delta) = \text{sqrt}(4\pi\rho r_0 / k^2)$$

$$k=2\pi/\lambda=4\text{\AA}^{-1}, b=r_0=2.82 \times 10^{-5}\text{\AA}, \rho=1e^{-}/\text{\AA}^3: \delta \approx 10^{-5}$$

[Ref. 1: Als-Nielsen & McMorrow p.66]

critical angle for Si

$$\alpha_c = \sqrt{2\delta} = \sqrt{4\pi\rho r_0/k^2}$$

Silicon: $\rho = 0.699 \text{ e-}/\text{\AA}^3$, $\lambda = 1\text{\AA}$

$$\alpha_c = \sqrt{4\pi \times 0.699 \times 2.82\text{e-}5 \times 1/(2\pi)^2}$$

$$= 0.0025 \text{ rad}$$

$$Q_c = (4\pi/\lambda) \sin\alpha_c = 0.032 \text{ \AA}^{-1}$$

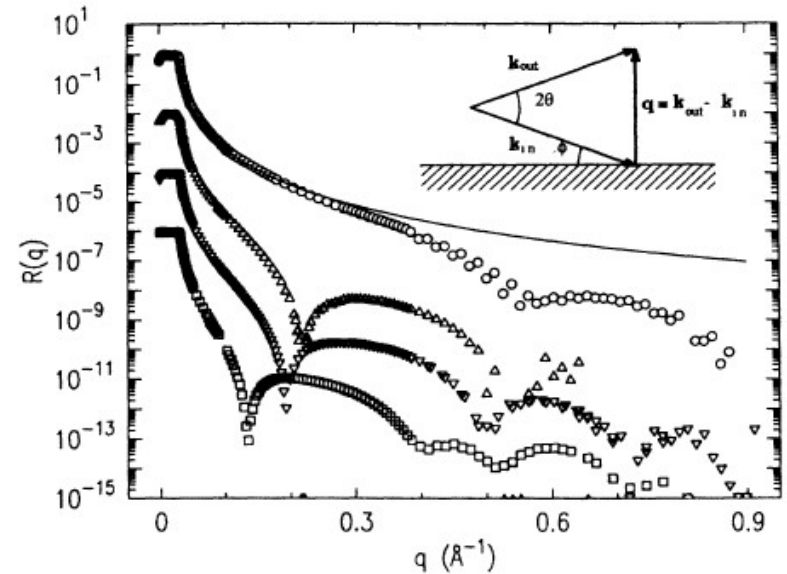
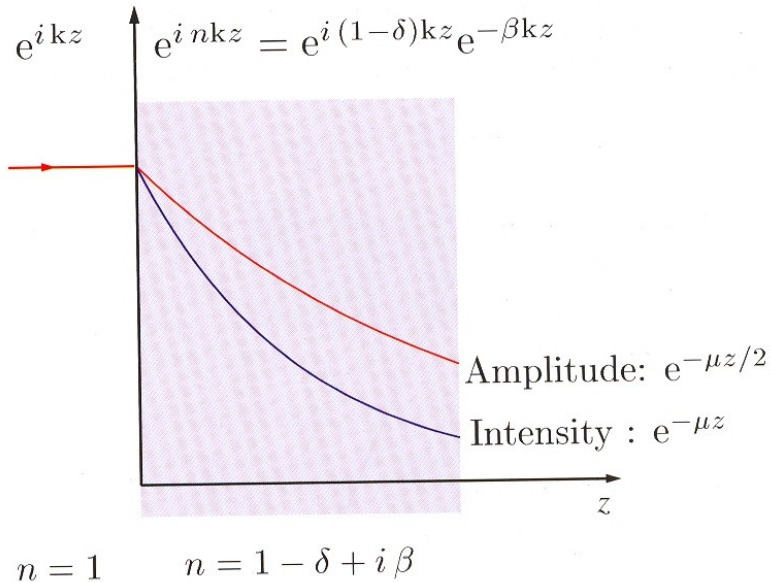


FIG. 1. Normalized reflectivity data from several samples. Successive data sets are displaced by 100 times and error bars omitted for clarity. (—) Theoretical reflectivity from an ideal step interface with bulk silicon density. (○) Uncoated silicon sample in helium; the “pairing” of points occurs for two scans taken 60 min apart and is probably due to the build up of contaminants on the surface. (△) 10-carbon chain alkylsiloxane. (▽) 12-carbon chain alkylsiloxane. (□) 18-carbon chain alkylsiloxane. The inset shows a schematic diagram of the scattering vectors for the specular reflectivity condition, where $2(\phi) = 2\theta$.

Refraction including absorption



$$n = 1 - \delta + i\beta$$

wave propagating in a medium:

$$\exp(inkz) = \exp(i(1-\delta)kz) \exp(-\beta kz)$$

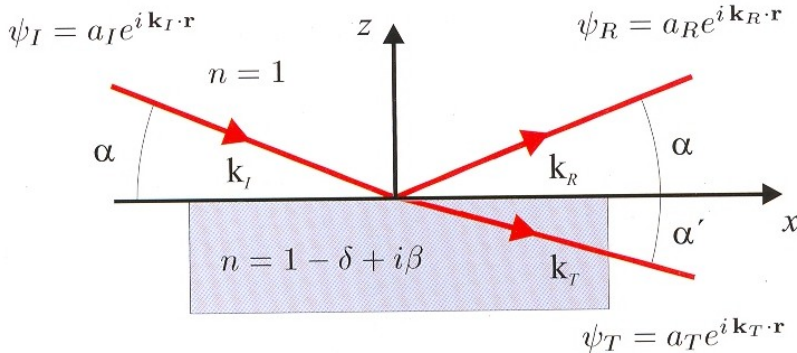
attenuation of amplitude: $\exp(-\mu z/2)$
 (when intensity drops according to $\exp(-\mu z)$)

$$\beta = \mu/2k$$

Snell's law and the Fresnel equations

Snell's law and the Fresnel equations

$$k = |\mathbf{k}_I| = |\mathbf{k}_R|$$



$$|\mathbf{k}_T| = nk$$

$$\parallel: a_I k \cos \alpha + a_R k \cos \alpha = a_T (nk) \cos \alpha' \quad (B')$$

$$\perp: -(a_I - a_R) k \sin \alpha = -a_T (nk) \sin \alpha' \quad (B'')$$

$$\boxed{\cos \alpha = n \cos \alpha'} \quad (B' + A)$$

$$\underline{\alpha, \alpha' \text{ small: } (\cos z = 1 - z^2/2)}$$

$$\begin{aligned} \alpha^2 &= \alpha'^2 + 2\delta - 2i\beta \\ &= \alpha'^2 + \alpha_c^2 - 2i\beta \end{aligned} \quad (C)$$

$$a_I - a_R / a_I + a_R = n(\sin \alpha' / \sin \alpha) \approx \alpha' / \alpha \quad (B'' + A)$$

Require that the wave and its derivative is continuous at the interface:

$$a_I + a_R = a_T \quad (A)$$

$$a_I \mathbf{k}_I + a_R \mathbf{k}_R = a_T \mathbf{k}_T \quad (B)$$

Fresnel equations:

$$r = a_R / a_I = (\alpha - \alpha') / (\alpha + \alpha')$$

$$t = a_T / a_I = 2\alpha / (\alpha + \alpha')$$

r: reflectivity t: transmittivity

Snell's law and the Fresnel equations (2)

Note: α' is a complex number

$$\alpha' = \text{Re}(\alpha') + i \text{Im}(\alpha')$$

Consider z-component of transmitted wave:

$$= a_T \exp(iks \sin \alpha' z) \approx a_T \exp(ik \alpha' z)$$

$$= a_T \exp(ik \text{Re}(\alpha') z) \cdot \exp(-k \text{Im}(\alpha') z)$$



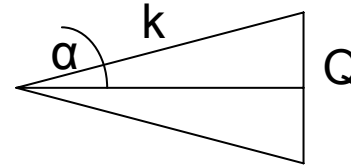
exponential damping

intensity fall-off: $\exp(-2k \text{Im}(\alpha') z)$

1/e penetration depth Λ : $z = 2k \text{Im}(\alpha') = 1$ ($z = \Lambda$)

$$\Lambda = 1 / 2k \text{Im}(\alpha')$$

use wavevector notation:



$$\sin \alpha = (Q/2)/k$$

$$Q \equiv 2k \sin \alpha \approx 2k \alpha$$

$$Q_c \equiv 2k \sin \alpha_c \approx 2k \alpha_c$$

use dimensionless units:

$$q \equiv Q/Q_c \approx (2k/Q_c) \alpha$$

$$q' \equiv Q'/Q_c \approx (2k/Q_c) \alpha'$$

$$q^2 = q'^2 + 1 - 2i b_u \quad (D)$$

$$b_u = (2k/Q_c) \beta = (4k^2/Q_c^2) \mu / 2k = 2k \mu / Q_c^2$$

$$Q_c = 2k \alpha_c = 2k \sqrt{2\delta}$$

Snell's law and the Fresnel equations (3)

use table to extract μ , ρ , f' yielding Q_c
and calculate b_u ($b_u \ll 1$):

$$b_u = 2k\mu/Q_c^2$$

use (D): $q^2 = q'^2 + 1 - 2ib_u$

	Z	Molar density (g/mole)	Mass density (g/cm ³)	ρ (e/Å ³)	Q_c (1/Å)	$\mu \times 10^6$ (1/Å)	b_μ
C	6	12.01	2.26	0.680	0.031	0.104	0.0009
Si	14	28.09	2.33	0.699	0.032	1.399	0.0115
Ge	32	72.59	5.32	1.412	0.045	3.752	0.0153
Ag	47	107.87	10.50	2.755	0.063	22.128	0.0462
W	74	183.85	19.30	4.678	0.081	33.235	0.0409
Au	79	196.97	19.32	4.666	0.081	40.108	0.0495

get:

$$r(q) = (q - q') / (q + q')$$

$$t(q) = 2q / (q + q')$$

$$\Lambda(q) = 1 / Q_c \operatorname{Im}(q')$$

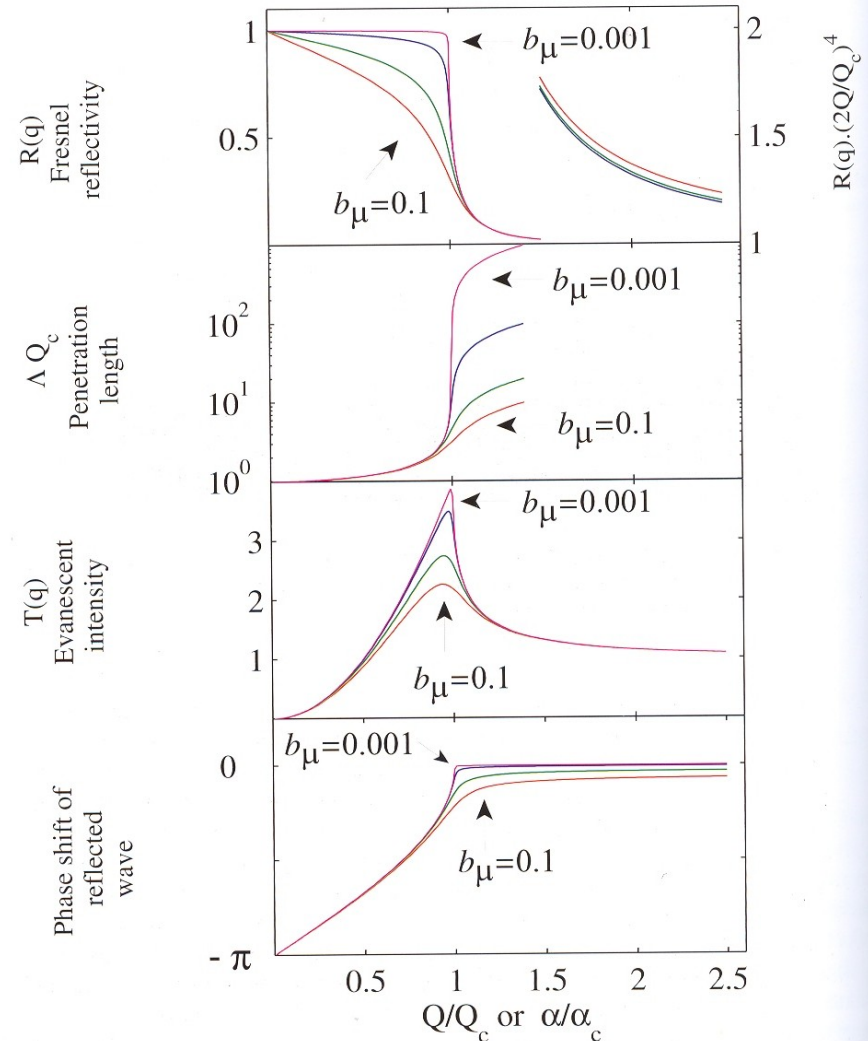
Snell's law and the Fresnel equations (4)

Fresnel equations:

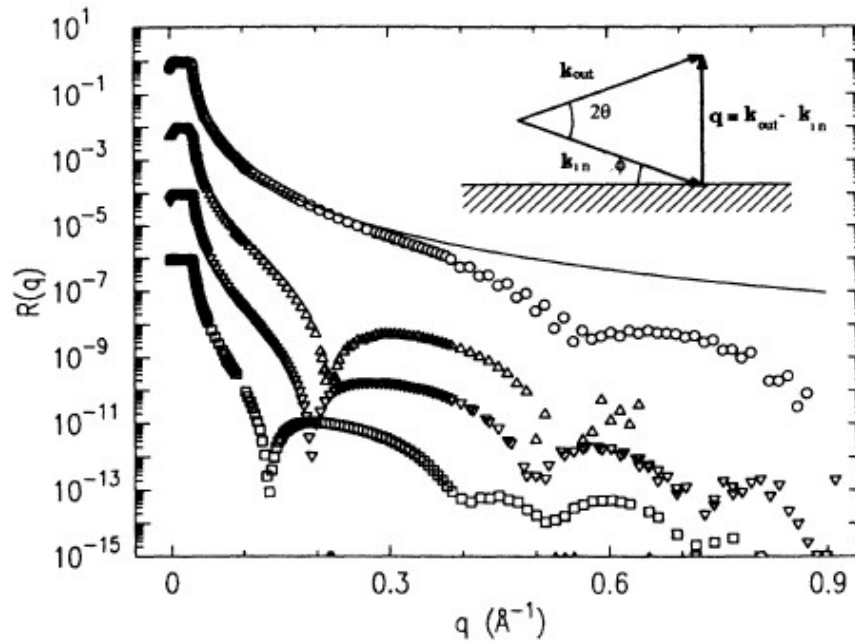
$q \gg 1$: $R(Q) \sim 1/q^4$,
 $\Lambda \approx \mu^{-1}$,
 $T \approx 1$,
 no phase shift

$q \ll 1$: $R \approx 1$,
 $\Lambda \approx 1/q_c$ small,
 T very small,
 $-\pi$ phase shift

$q = 1$: $T(q=1) \approx 4 a_1$



Examples



PHYSICAL REVIEW B

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X-ray specular reflection studies of silicon coated by organic monolayers (alkylsiloxanes)

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(Received 3 October 1988; revised manuscript received 7 August 1989)

FIG. 1. Normalized reflectivity data from several samples. Successive data sets are displaced by 100 times and error bars omitted for clarity. (—) Theoretical reflectivity from an ideal step interface with bulk silicon density. (○) Uncoated silicon sample in helium; the “pairing” of points occurs for two scans taken 60 min apart and is probably due to the build up of contaminants on the surface. (△) 10-carbon chain alkylsiloxane. (▽) 12-carbon chain alkylsiloxane. (□) 18-carbon chain alkylsiloxane. The inset shows a schematic diagram of the scattering vectors for the specular reflectivity condition, where $2(\phi) = 2\theta$.